



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 31, 2024

IGI Report Number **LG645432775**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **7.48 X 5.56 X 3.89 MM**

GRADING RESULTS

Carat Weight **1.59 CARAT**

Color Grade **H**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

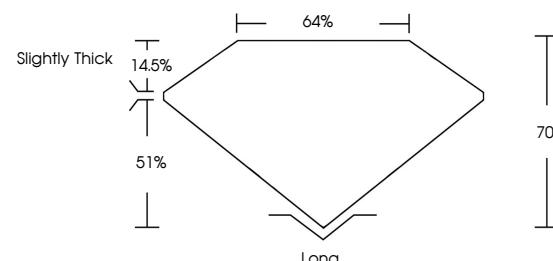
Fluorescence **NONE**

Inscription(s) **IGI LG645432775**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

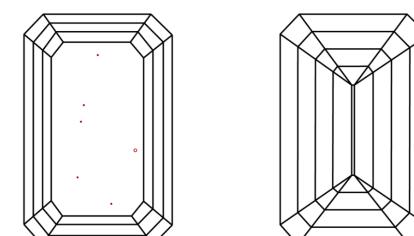
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG645432775
Report verification at igi.org

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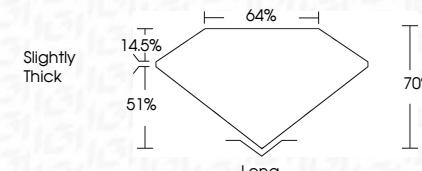
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IGI

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July 31, 2024	IGI Report No LG645432775	BMEERALD CUT	1.59 CARAT	H	VS 1	70%	64%	Slightly Thick	Long	EXCELLENT	EXCELLENT	NONE	IGI LG645432775
Carat Weight	1.59 CARAT	Color Grade	H	Clarity Grade	VS 1	Depth	64%	Table Grade	Culet	Polish	Symmetry	Fluorescence	Inscription(s)
Measurements	7.48 X 5.56 X 3.89 MM	Depth	70%	Table Grade	VS 1	Light							
Comments:	This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.												Type IIa

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